72CP2D3CD PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Policant

Halpin et al.

Appl. No.

10/642,799

Filed

: August 18, 2003

For

WAFER SUPPORT SYSTEM

Examiner

Unknown

## Group Art Unit Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: United States Patent and Trademark Office, PO Box 1450, Alexandria, VA 22313-1450, on

December 5, 2003

(Date)

Tina Chen, Reg. No. 44,605

## REQUEST FOR CORRECTION OF INVENTORSHIP UNDER 37 C.F.R. § 1.1324

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby request that the following persons, originally named upon filing of the above-captioned application, be deleted from the inventorship of the above-captioned application:

Frank B. Van Bilsen;

Matthew Goodman;

Glenn Hartmann; and

Jason M. Layton.

This deletion is necessitated by an earlier cancellation of claims, such that the above-listed inventors' invention(s) is/are no longer claimed in the above-captioned application.

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130.00 OP

Appl. No.

Filed

August 18, 2003

Enclosed is a check in the amount of \$130 for the statutory fee required under 37 C.F.R. §1.17(i).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: December 5, 2003

By: Tina Chen

Registration No. 44,606 Attorney of Record Customer No. 20,995 (415) 954-4114

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